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Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Re: U.S. Patent No. 6,952,622

Issued: October 4, 2005

For: Robot Pre-Positioning in a Wafer Processing System

Patentees: BABIKIAN et al. Our Ref: 1857.6800003

Sir:

Transmitted herewith for appropriate action are the following documents:

- 1. Power of Attorney to Prosecute Applications Before the USPTO; and
- 2. Statement Under 37 C.F.R. 3.73(b).

The above-listed documents are filed electronically through EFS-Web.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted.

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

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GJP/awt Enclosures

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